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| Notice of References Cited | Application/Control No. 10/084,241 | Applicant(s)/Patent Under Reexamination HAO ET AL | |
| | Examiner Jia W. Lu | Art Unit 2634 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|------------------|----------------|
| | A | US-5,103,459 | 04-1992 | Gilhousen et al. | 370/206 |
| | B | US-5,414,728 | 05-1995 | Zehavi, Ephraim | 375/142 |
| | C | US-5,416,797 | 05-1995 | Gilhousen et al. | 370/209 |
| | D | US-5,533,012 | 07-1996 | Fukasawa et al. | 370/342 |
| | E | US-6,088,347 | 07-2000 | Minn et al. | 370/342 |
| | F | US-2001/0053178 | 12-2001 | Yano et al. | 375/150 |
| | G | US-2002/0003842 | 01-2002 | Suzuki et al. | 375/259 |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|-----------------|-----------|----------------|
| | N | WO0045530A1 | 03-2000 | (PCT) CN, JP, U | FAN et al | H04B 7/26 |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

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